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CONFIRMATION NO. 9376

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/815,813	<b>FILING OR 371(c) DATE</b> 04/02/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2814	<b>ATTORNEY DOCKET NO.</b> 0756-7283	
<b>APPLICANTS</b> Koichiro Tanaka, Atsugi, JAPAN; Hidekazu Miyairi, Tochigi, JAPAN; Hironobu Shoji, Machida, JAPAN;					
<b>** CONTINUING DATA *****</b>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-101312 04/04/2003					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 06/16/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 15	<b>TOTAL CLAIMS</b> 46	<b>INDEPENDENT CLAIMS</b> 8
<b>ADDRESS</b> 31780					
<b>TITLE</b> Method of fabricating semiconductor device utilizing laser irradiation					
<b>FILING FEE RECEIVED</b> 1668	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

8/15/06